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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Toshinori Ota et al.

Date: August 29, 2006

Serial No.: 10/555,855

Group Art Unit: 1753

Filed: November 7, 2005

Examiner: ---

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC
SEMICONDUCTOR ELEMENT USING THERMOELECTRIC SEMICONDUCTOR
MATERIAL, THERMOELECTRIC MODULE USING THERMOELECTRIC
SEMICONDUCTOR ELEMENT AND MANUFACTURING METHOD FOR SAME

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Respectfully submitted,

Robert C. Faber

Name of applicant, assignee or
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Signature

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**APPLICANT'S ART
CITATION**

(Use several sheets if necessary)

Application **10/555,855**

OFOS File No. **P/2850-120**

Applicant **Toshinori OTA et al.**

Filing Date **November 7, 2005**

Group Art Unit **1753**

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Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
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Examiner /Golam Mowla/	Date Considered 02/23/2010
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	